Application Number Docket Number (Optional) 10/601,496 Applicant(s) Takeshi Ozawa, et al. TION DISCLOSURE CITATION (Use several sheets if necessary) Filing Date Group Art Unit Unassigned June 23, 2003 **U.S. PATENT DOCUMENTS** EXÂMINER FILING DATE CLASS SUBCLASS REF DOCUMENT NUMBER DATE NAME INITIAL IF APPROPRIATE FOREIGN PATENT DOCUMENTS Translation REF DOCUMENT NUMBER DATE COUNTRY CLASS SUBCLASS YES NO EP 1 256 310 A2 11/13/2002 **EPO** ALOTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) U.S. Patent Application Publication No. US 2002/0062061 A1, pub; ished May 23, 2002, issued to Kaneko et al. AL

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/Alex Kok Liew/ (09/01/2006)

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